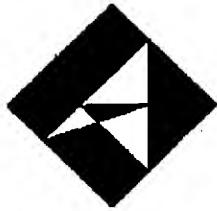


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AUG 26 2004

To: Examiner Porfirio Nazario Gonzalez, Fax: 703.872.9306
 From: Mag Chappuis Date: August 26 2004
 E-mail: Mchappuis@atmi.com Pages: 32
 Re: Response to February 26, 2004 Office cc:
 Action in U.S. Application Serial No.
 09/954,831

OFFICIAL COMMUNICATION

AMENDMENT RESPONDING TO FEBRUARY 26, 2004 OFFICE ACTION IN U.S. PATENT
 APPLICATION NO. 09/954,831 AND PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R.
 § 1.136

Dear Examiner Nazario Gonzalez:

Please find enclosed a Response to the February 26, 2004 Office Action in US Patent Application No. 09/954,831, for Source Reagent Compositions for CVD Formation of Gate Dielectric Thin Films Using Amide Precursors and Method of Using Same, including:

Response - 21 sheets
 Appendix A - 10 sheets
 Facsimile Transmittal - 1 sheet

Please call 203-739-1435 if there are any problems with this transmittal.

Maggie Chappuis

ATMI, Inc.
 7 Commerce Drive
 Danbury, CT 06810
 203-794-1100 (telephone)
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 ATMI Docket: ATM-510 CIP

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